Claims

- [c1] 1.A method for scanning specimens using an optical imaging system and a scanning stage, comprising the steps of:
 - -calibrating the scanning stage by obtaining and storing height values Z at different calibration positions X, Y of the scanning stage, and thereby generating a height profile of the scanning stage;
 - -scanning specimens, and thereby
 - -- determining a reference height Z_{ref} of the specimen at the beginning of a specimen scan,
 - -- traveling to specimen points X_p , Y_p using the scanning stage,
 - -- setting, while traveling to specimen point X_p , Y_p , a specimen height position Z_p pertinent to the respective specimen point X_p , Y_p , the specimen height position Z_p being determined from the reference height Z_{ref} and the height profile of the scanning stage, and
 - -- acquiring an image and/or performing a measurement at specimen point X_p , Y_p .
- [c2] 2.The method as defined in Claim 1, wherein images of the specimen are acquired by means of a camera, and/or

measurements on the specimen being made by means of an optical measurement device, at specimen points X_p , Y_p .

- [c3] 3.The method as defined in Claim 1, wherein the reference height Z_{ref} of the specimen is identified at the beginning of the specimen scan by focusing with a focusing system at a reference location X_{ref} , Y_{ref} of the specimen.
- [c4] 4.The method as defined in Claim 1, wherein upon calibration of the scanning stage, the height values Z are obtained by focusing with a focusing system.
- [c5] 5.The method as defined in claim 1, wherein during the specimen scan, the image is acquired and/or the measurement is made without stopping the scanning stage at the specimen point X_p , Y_p .
- [c6] 6.The method as defined in one of the foregoing claims, wherein with specimen points X_p , Y_p arranged line-by-line, the specimen points X_p , Y_p are scanned in meander fashion.
- [c7] 7.The method as defined in claim 1, wherein the height values Z identified at the calibration positions X, Y are stored in a lookup table.

- [08] 8. The method as defined in claim 1, wherein the specimen height positions Z_p at the specimen points X_p , Y_p are determined, by interpolation or mathematical approximation functions, from the height profile of the scanning stage.
- [c9] 9.The method as defined in Claim 7, wherein if the calibration positions X, Y and specimen points X_p , Y_p are coincident, the specimen height position Z_p is determined from the corresponding height value Z from the lookup table, and the reference height Z_{ref} .
- [c10] 10. The method as defined in claim 1, wherein for calibration of the scanning stage, a flat substrate is placed onto the scanning stage.
- [c11] 11.The method as defined in claim 1, wherein the optical imaging system is a microscope.
- [c12] 12. The method as defined in claim 1, wherein the optical imaging system is a macroscope.
- [c13] 13. The method as defined in claim 3, wherein the focus-ing system is an LED or laser autofocus system.
- [c14] 14. The method as defined in claim 2, wherein an image field of the camera and the spacings of the specimen points X_p , Y_p are selected in such that an image of the

entire specimen results when the images of all the specimen points X_p , Y_p are juxtaposed.

- [c15] 15.An apparatus for scanning specimens using an optical imaging system and a scanning stage, comprises:

 a control unit for displacing the scanning stage, to at least one calibration position X, Y during a calibration of the scanning stage in order to obtain a height profile of the scanning stage; to specimen at least one specimen point X, Y, during scanning of the specimen; and for setting a specimen height position Z, at each specimen point X, Y;
 - -a memory for storing the height profile of the scanning stage;
 - -a computation unit for determining the specimen height position Z_p at the respective specimen points X_p , Y_p from a reference height Z_{ref} of the specimen and from the height profile of the scanning stage; and -an optical device for acquiring data at each specimen point X_p , Y_p .
- [c16] 16. The apparatus as defined in Claim 15, wherein the optical device is a camera for acquiring images at each specimen point X_p , Yp
- [c17] 17. The apparatus as defined in Claim 15, wherein the optical device is an optical measurement device for per-

forming a measurement at specimen points X_p , Y_p .

- [c18] 18. The apparatus as defined in Claim 15, wherein a focusing system is provided at least for focusing onto at least one reference location X_{ref} , Y_{ref} in order to obtain a reference height value Z_{ref} .
- [c19] 19. The apparatus as defined in one of Claim 15, wherein the optical imaging system is a microscope.
- [c20] 20.The apparatus as defined in one of Claim 15, wherein the optical imaging system is a macroscope.
- [c21] 21. The apparatus as defined in Claim 17, wherein the measurement device is an optical spectrometer, an ellipsometer, or a layer thickness measurement system.